

2671

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

John Erik Lindholm et al.

Application No. 09/960,004

Filed: September 20, 2001

For: MASKING SYSTEM AND METHOD FOR
A GRAPHICS PROCESSING FRAMEWORK
EMBODIED ON A SINGLE SEMICONDUCTOR
PLATFORM

Group Art Unit: 2671

Examiner: Unassigned

Atty. Docket No. NVIDP008B/
P000057

Date: May 1, 2002

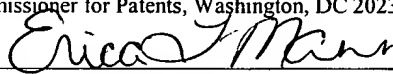
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the
United States Postal Service as First Class Mail in an envelope addressed
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Signed:


Erica L. Mann

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§ 1.56 AND 1.97(b)

Commissioner for Patents
Washington, DC 20231

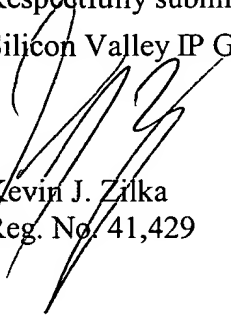
Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-1351 (Order No. NVIDP008B/P000057).

Respectfully submitted,
Silicon Valley IP Group



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| Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary) | Atty. Docket No. NVIDP008B/P000057 | Application No.: 09/960,004 |
| | Applicant: John E. Lindholm et al. | |
| | Filing Date: 09/20/2001 | Group Art Unit: 2671 |
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U.S. Patent Documents

| Examiner Initial | No. | Patent No. | Date | Patentee | Class | Sub-class | Filing Date |
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| | B | 6,014,144 | 01/11/00 | Nelson et al. | 345 | 426 | 02/03/98 |
| | C | 6,163,319 | 12/19/00 | Peercy et al. | 345 | 426 | 03/09/99 |
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| | G | | | | | | |
| | H | | | | | | |
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| | J | | | | | | |
| | K | | | | | | |

Foreign Patent or Published Foreign Patent Application

| Examiner Initial | No. | Document No. | Publication Date | Country or Patent Office | Class | Sub-class | Translation | |
|------------------|-----|--------------|------------------|--------------------------|-------|-----------|-------------|----|
| | | | | | | | Yes | No |
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Other Documents

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| Examiner Initial | No. | Author, Title, Date, Place (e.g. Journal) of Publication | Technology Center 2600 |
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| | R | | |
| | S | | |
| | T | | |
| Examiner | | Date Considered | |

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.